

Docket No.: 4425-320

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|---|---|-------------------------|
| In re Application of | : | |
| Chien-Hsin LAI et al. | : | Confirmation No. 3535 |
| Application No. 10/659,258 | : | Group Art Unit: 1763 |
| Filed: September 11, 2003 | : | Examiner: KARLA A MOORE |
| For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE MATCHING | | |

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

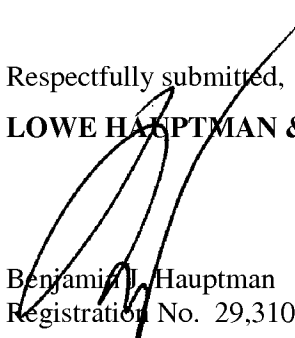
Dear Sir:

Applicant(s) hereby petition(s) the Commissioner of Patents and Trademarks to extend the time for response to the Official Action dated September 12, 2006 for 1 month month(s) from December 12, 2006 to January 12, 2007.

A credit card authorization form to cover the cost of the extension is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No.: 07-1337.

Respectfully submitted,

LOWE HAUPTMAN & BERNER, LLP


Benjamin J. Hauptman
Registration No. 29,310

1700 Diagonal Road, Suite 310
Alexandria, Virginia 22314
Telephone: (703) 684-1111
Facsimile: (703) 518-5499
DATE: January 12, 2007
BJH:AYW